

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	
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Yoshiharu OHTA et al.	:	Confirmation No. 4867
	:	
U.S. Patent Application No. 10/594,635	:	Group Art Unit: 1793
	:	
Filed: September 28, 2006	:	Examiner: Shuangyi Abu ALI

For: SEMICONDUCTOR POLISHING COMPOSITION

EXPRESS ABANDONMENT

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

I request that the above-identified application be expressly abandoned, without prejudice or disclaimer, as of the filing date of this paper.

I am an attorney of record. My attorney registration number is 45,943.

The Examiner's position in the Office Action is duly noted. This decision is related to business, not the merits of anything said in this record.

Respectfully submitted,

LOWE HAUPTMAN HAM & BERNER, LLP

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